

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re application of: Satya, et al.

Attorney Docket No.: KLA1P016F/P642

Application No.: 09/648,095

Examiner: Quang D. Vu

Filed: August 25, 2000

Group: 2811

Title: CHEMICAL MECHANICAL POLISHING  
TEST STRUCTURES AND METHODS  
FOR INSPECTING THE SAME

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**AMENDMENT H**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

It is respectfully submitted that the Examiner enter the following amendments in response to the Office Action dated 27 March 2006, a response which is due 27 June 2006.

**Amendments to the Claims** are reflected in the listing of claims which begin on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.